

**RESPONSE UNDER 37 C.F.R. § 1.111  
EXAMINING GROUP 1765**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : K.R. Udayakumar et al. Confirmation No.: 8320  
Application Number : 10/721,932  
Filed : November 25, 2003  
Title : METHOD FOR ETCHING A SUBSTRATE AND A DEVICE  
FORMED USING THE METHOD  
TC/Art Unit : 1765  
Examiner: : Lan VINH  
  
Docket No. : TI-35507 (0025.0203)  
Customer No. : **23494**

**MAIL STOP AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Responsive to the Office Action mailed September 27, 2007, and pursuant to  
37 C.F.R. § 1.111, please amend this application as follows:

**Current Claims** are reflected in the listing of claims in this paper beginning at  
page 2.

**Remarks** begin at page 8.